IAP5 Rec'd PCT/PTO 30 AUG 2006

NY-AFILM-204-US

10/591156

I hereby certify that this correspondence is being sent by Express Mail No: EV 793663865 US in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: 8 30 06 Signature:

(Eileen Sheffield)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hoffmann, et al.

Application No.: Please assign

Confirmation No.:

Filed: herewith

Art Unit: N/A

For: SUBSTRATE COMPRISING A FABRY-

PEROT FILTER AND METHOD FOR APPLICATION OF THE FILTER TO THE

SUBSTRATE

Examiner: Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

While the information and references disclosed in this Information Disclosure Statement may be "material" pursuant to 37 CFR 1.56, it is not intended to constitute an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

These references were cited in International Search Report of PC/DE2004/000392 filed March 1, 2004.

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In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Commissioner is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0624, under Order No. NY-AFILM-204 US. A duplicate copy of this paper is enclosed.

Respectfully submitted

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PTO/SB/08A (10-01) Approved for use through 10/31/2002.OMB 0651-0031

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Sub				Complete if Known / 5 9115		
				Application Number		
INFORMATION DISCLOSURE				Filing Date		
STATEMENT BY APPLICANT			APPLICANT	First Named Inventor	Hoffmann, et al.	
			•	Art Unit		
(use as many sheets as necessary)				Examiner Name		
Sheet	1	of	1	Attorney Docket Number	AFILM-204-US	

U.S. PATENT DOCUMENTS						
Examiner	Cite	Document Number	Publication Date	Name of Patentee or Applicant	Pages, Columns, Lines, Where Relevant	
Initials*	No.1	Number-Kind Code ² (if known)	MM-DD-YYYY	of Cited Document	Passages or Relevant Figures Appear	
	AA	US-5,182,670 A	1/26/93	Khan, et al.		
	AB	US-2002/197459 A1	12/26/02	Huhn, et al.		
	AC	US-6,451,184 B1	9/17/02			
	AD	US-6,200,431 B1	3/13/01			

FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or	Pages, Columns, Lines Where Relevant	
		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)		Applicant of Cited Document	Passages or Relevant Figures Appear	⊤⁰
	BA	DE-198 34 734 A	2/10/00	Fraunhofer Ges Forschung		T
	ВВ	DE-198 45 268 C	1/5/00	Fraunhofer Ges Forschung		T
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NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²		
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